



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#17

Response

J. McMillan

10/28/02

TECHNOLOGY CENTER 2800

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In re Patent Application of:

Shinji TAKEDA et al.

Serial No. 09/785,486

Filed: February 20, 2001

For: SEMICONDUCTOR DEVICE AND  
PROCESS FOR FABRICATION  
THEREOF

)  
) Atty. Docket No.: TM&K0008  
)  
) Group Art Unit: 2814  
)  
) Examiner: GRAYBILL, D.  
)  
)  
) Date: October 16, 2002  
)  
)

SUPPLEMENTAL TO AMENDMENT (B)

**Box: No Fee Amendment**

Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the official Office Action dated December 19, 2001, and in response to the official Office Communication dated September 16, 2002, Applicants provide the following additional remarks.

**REMARKS**

Applicant responds below to the Examiner's request for information under 37 C.F.R.

1.105, being directed to identification of what is being improved (Office Action, dated December 19, 2001, page 9, lines 5-20). Applicant also provides additional remarks showing how the Declaration filed under 37 C.F.R. 1.132 by Takashi Masuko (hereafter, the "Masuko Declaration") provides evidence of superior and unexpected results that are commensurate in scope with the claims.

The following additional remarks are to be considered along with Applicants' Amendment (B) filed on June 19, 2002, which is incorporated herein by reference.